



Initial Review
BOX AF

730-117

AF 1107

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hidehiko KIRA et al.

Serial Number: 08/393,677

Filed: February 24, 1995

For: METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE

RECEIVED

JUN 13 1997

GROUP 1100

Group Art Unit: 1107

Examiner: David E. GRAYBILL

16 B
6-16-97
U. Ross
NE/C
#20 mR
12/11/97

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1107

DO NOT ENTER
6-17-97

BOX AF

Assistant Commissioner for Patents
Washington, D.C. 20231

May 30, 1997

Sir:

In response to the Office Action dated December 4, 1996, please amend the above-identified application as follows:

IN THE CLAIMS:

Amend claim 1 as follows:

1. (Twice Amended) A fabrication method of a semiconductor device comprising

the steps of:

C

[Handwritten signature]

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